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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard S.3). ⁴For Japanese patent documents, the indication of the year of reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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Complete if Known Substitute for Form 1449A/PTO (Modified) 09/883,036 **INFORMATION DISCLOSURE Application Number** June 11, 2001 Filing Date MENT BY APPLICANT First Named Inventor: Qing Ma as many sheets as necessary) Group Art Unit 2811 DEC 1 7 2002 **Examiner Name** Not Yet Assigned Attorney Docket Number 42390.P11430 2 of Scheet PRADEM OTHER ART - NO PATENT LITERATURE DOCUMENTS T^2 Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the Cite Examiner item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue Initials* No¹ number(s), publisher, city and/or country where published HSU, WAN-THAI et al., "Mechanically Temperature-Compensated Flexural-Mode Micromechanical Resonators", International Electron Devices Meeting 2000. IEDM. Technical Digest, San Francisco, CA, (December 10-13, 2000), New York: IEEE, US (December 10, 2000) Pages 399-402. ADAMS, SCOTT G. et al., "Independent Tuning Of Linear And Nonlinear Stiffness Coefficients", Journal of Microelectromechanical Systems, Vol. 7, No. 2, (June 1998), pages NGUYEN, CLARK T.-C, "Micromachining Technologies For Miniaturized Communication Devices". SPIE Conference on Micromaching and Microfabrication Process Technology IV, Santa Clara, California (September 1998) Vol. 3511, pages 24-38.

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